

INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449  EP 2 9 2008 w	Docket No. 52433/820	Application No. 10/551,159
	Applicant(s) TANAKA et al.	Examiner Michael E. Lavilla
	Filing Date September 28, 2005	Confirmation No. 3164



U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS

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EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
JZ/	Chinese Office Action dated 27 June 2008 issued in corresponding Chinese Application No. 2004800090110.

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /JZ/